

Docket No.: 052775-0024



IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Masahiro NAKAYAMA, et al.	:	Confirmation Number: 1716
Application No.: 10/662,524	:	Group Art Unit: 2826
Filed: September 16, 2003	:	Examiner: not yet assigned

For: CHAMFERED FREESTANDING NITRIDE SEMICONDUCTOR WAFER AND
METHOD OF CHAMFERING NITRIDE SEMICONDUCTOR WAFER

STATUS INQUIRY

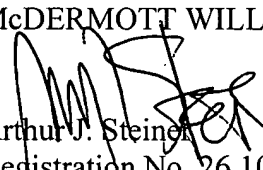
Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A patent application was filed in the referenced application on September 16, 2003. Since more than twenty-one months have elapsed since that date, and no response to said patent application has been received by attorney for applicant, Applicant respectfully requests that the undersigned attorney be informed of the status of the referenced application.

Respectfully submitted,

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**Please recognize our Customer No. 20277
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